



Attorney's Docket No.: 14225-049001 / F1040149US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kiyoshi Mita  
Serial No. : 10/813,782  
Filed : March 31, 2004  
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Art Unit : 2815  
Examiner : Chris C. Chu

**MAIL STOP RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Prior to examination, please amend the application as indicated on the following pages.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

October 18, 2005

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